Attorney's Docket 040258-0280192
Client Reference: EL00028CDC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of: Confirmation Number: 5539
TOMOHISA HOSHINO ET AL.

Application No.: 09/835,820   Group Art Unit: 2825

Filed: April 17, 2001   Examiner: Luu, Chuong A.

For: FABRICATING PROCESS OF A SEMICONDUCTOR DEVICE INCL UDING A CVD PROCESS OF A METAL FILM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

FEES

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	16	– 20	= 0	x $ 18.00 =	$ 0.00
INDEP.	3	– 3	= 0	x $ 86.00 =	$ 0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+ $ 290.00 =	$ 0.00
			TOTAL ADDITIONAL CLAIM FEE		$ 0.00
			GRAND TOTAL		$ 0.00

FEE PAYMENT

Authorization is hereby made to charge the amount of $0.00 to Deposit Account No. 033975. Charge any additional fees required by this paper or credit any overpayment in the manner authorized above. A duplicate of this paper is attached.

John P. Darling 44,482
John P. Darling

Date: May 11, 2004
PILLSBURY WINTHROP LLP   for JEFFREY D. KARCESKI
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May 11, 2004

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AMENDMENT

Hon. Commissioner of Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313

Sir:

In response to the Office Action dated March 17, 2004, please amend the above identified application as follows.